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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
09/989,372	11/21/2001	Richard H. Lane	M4065.0338/P338-A	1348
24998	7590	04/21/2004	EXAMINER	
DICKSTEIN SHAPIRO MORIN & OSHINSKY LLP 2101 L STREET NW WASHINGTON, DC 20037-1526			DOAN, THERESA T	
			ART UNIT	PAPER NUMBER

2814

DATE MAILED: 04/21/2004

Please find below and/or attached an Office communication concerning this application or proceeding.

Office Action Summary

Application No.

09/989,372

Applicant(s)

LANE, RICHARD H.

Examiner

Theresa T Doan

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-- The MAILING DATE of this communication appears on the cover sheet with the correspondence address --

Period for Reply

A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 03 MONTH(S) FROM THE MAILING DATE OF THIS COMMUNICATION.

- Extensions of time may be available under the provisions of 37 CFR 1.136(a). In no event, however, may a reply be timely filed after SIX (6) MONTHS from the mailing date of this communication.
- If the period for reply specified above is less than thirty (30) days, a reply within the statutory minimum of thirty (30) days will be considered timely.
- If NO period for reply is specified above, the maximum statutory period will apply and will expire SIX (6) MONTHS from the mailing date of this communication.
- Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED (35 U.S.C. § 133).
- Any reply received by the Office later than three months after the mailing date of this communication, even if timely filed, may reduce any earned patent term adjustment. See 37 CFR 1.704(b).

Status

- 1) ☒ Responsive to communication(s) filed on 05 March 2004.
- 2a) ☐ This action is FINAL. 2b) ☒ This action is non-final.
- 3) ☐ Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under *Ex parte Quayle*, 1935 C.D. 11, 453 O.G. 213.

Disposition of Claims

- 4) ☒ Claim(s) 29-32, 34-39, 41, 44-47, 49 and 51-64 is/are pending in the application.
- 4a) Of the above claim(s) _____ is/are withdrawn from consideration.
- 5) ☐ Claim(s) _____ is/are allowed.
- 6) ☒ Claim(s) 29-32, 34-39, 41, 44-47, 49 and 51-64 is/are rejected.
- 7) ☐ Claim(s) _____ is/are objected to.
- 8) ☐ Claim(s) _____ are subject to restriction and/or election requirement.

Application Papers

- 9) ☐ The specification is objected to by the Examiner.
- 10) ☐ The drawing(s) filed on _____ is/are: a) ☐ accepted or b) ☐ objected to by the Examiner.
Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).
- 11) ☐ The proposed drawing correction filed on _____ is: a) ☐ approved b) ☐ disapproved by the Examiner.
If approved, corrected drawings are required in reply to this Office action.
- 12) ☐ The oath or declaration is objected to by the Examiner.

Priority under 35 U.S.C. §§ 119 and 120

- 13) ☐ Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).
a) ☐ All b) ☐ Some * c) ☐ None of:
1. ☐ Certified copies of the priority documents have been received.
2. ☐ Certified copies of the priority documents have been received in Application No. _____.
3. ☐ Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)).
* See the attached detailed Office action for a list of the certified copies not received.
- 14) ☐ Acknowledgment is made of a claim for domestic priority under 35 U.S.C. § 119(e) (to a provisional application).
a) ☐ The translation of the foreign language provisional application has been received.
- 15) ☐ Acknowledgment is made of a claim for domestic priority under 35 U.S.C. §§ 120 and/or 121.

Attachment(s)

- 1) ☐ Notice of References Cited (PTO-892)
- 2) ☐ Notice of Draftsperson's Patent Drawing Review (PTO-948)
- 3) ☐ Information Disclosure Statement(s) (PTO-1449) Paper No(s) _____
- 4) ☐ Interview Summary (PTO-413) Paper No(s) _____
- 5) ☐ Notice of Informal Patent Application (PTO-152)
- 6) ☐ Other: _____

DETAILED ACTION

Request for Continued Examination

1. A request for continued examination under 37 CFR 1.114, including the fee set forth in 37 CFR 1.17(e), was filed in this application after final rejection. Since this application is eligible for continued examination under 37 CFR 1.114, and the fee set forth in 37 CFR 1.17(e) has been timely paid, the finality of the previous Office action has been withdrawn pursuant to 37 CFR 1.114. An action on the RCE follows.

The amendment filed on 03/05/04 has been entered.

Claim Rejections - 35 USC § 112

2. The following is a quotation of the first paragraph of 35 U.S.C. 112:

The specification shall contain a written description of the invention, and of the manner and process of making and using it, in such full, clear, concise, and exact terms as to enable any person skilled in the art to which it pertains, or with which it is most nearly connected, to make and use the same and shall set forth the best mode contemplated by the inventor of carrying out his invention.

3. Claims 29-35 are rejected under 35 U.S.C. 112, first paragraph, as failing to comply with the enablement requirement. The claim(s) contains subject matter which was not described in the specification in such a way as to enable one skilled in the art to which it pertains, or with which it is most nearly connected, to make and/or use the invention.

The limitations of "an insulating layer provided over said substrate; and **an electropolished patterned metal layer provided over said insulating layer**, wherein said electropolished metal layer has a thickness of approximately 50 to 300 Angstroms and wherein a top surface of said electropolished metal layer is electropolished down to

said insulating layer so that **said top surface of the electropolished metal layer is below or at the same level with a top surface of the insulating layer**", as recited in claim 29, are not described in the specification in such a way as to enable one skilled in the art to which it pertains, or with which it is most nearly connected, to make and/or use the invention.

4. The following is a quotation of the second paragraph of 35 U.S.C. 112:

The specification shall conclude with one or more claims particularly pointing out and distinctly claiming the subject matter which the applicant regards as his invention.

5. Claims 29-35 are rejected under 35 U.S.C. 112, second paragraph, as being indefinite for failing to particularly point out and distinctly claim the subject matter which applicant regards as the invention.

The limitations of "an insulating layer provided over said substrate; and an electropolished patterned metal layer provided over said insulating layer, wherein said electropolished metal layer has a thickness of approximately 50 to 300 Angstroms and wherein a top surface of said electropolished metal layer is electropolished down to said insulating layer so that said top surface of the electropolished metal layer is below or at the same level with a top surface of the insulating layer" as recited in claim 29 are too vague because the top surface of the electropolished metal layer 70 could not be below or at the same level with a top surface of **the insulating layer 24** and if the top surface of the electropolished metal layer 70 is below or at the same level with a top surface of **the insulating layer 25**, the electropolished patterned metal layer 70 would be formed

within said insulating layer 25, so the electropolished patterned metal layer 70 could not be provided **over said insulating layer 25** (see figure 12 of the instant invention).

Claim Rejections - 35 USC § 102

6. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless –

(e) the invention was described in a patent granted on an application for patent by another filed in the United States before the invention thereof by the applicant for patent, or on an international application by another who has fulfilled the requirements of paragraphs (1), (2), and (4) of section 371(c) of this title before the invention thereof by the applicant for patent.

The changes made to 35 U.S.C. 102(e) by the American Inventors Protection Act of 1999 (AIPA) and the Intellectual Property and High Technology Technical Amendments Act of 2002 do not apply when the reference is a U.S. patent resulting directly or indirectly from an international application filed before November 29, 2000. Therefore, the prior art date of the reference is determined under 35 U.S.C. 102(e) prior to the amendment by the AIPA (pre-AIPA 35 U.S.C. 102(e)).

7. Claims 29-32, 34-39, 41 and 51-64 are rejected under 35 U.S.C. 102(e) as being anticipated by Agarwal et al. (U.S. 6,297,527).

The applied reference has a common Assignee with the instant application. Based upon the earlier effective U.S. filing date of the reference, it constitutes prior art under 35 U.S.C. 102(e). This rejection under 35 U.S.C. 102(e) might be overcome either by a showing under 37 CFR 1.132 that any invention disclosed but not claimed in

the reference was derived from the inventor of this application and is thus not the invention "by another," or by an appropriate showing under 37 CFR 1.131.

Regarding claims 29-32 and 34-35, Agarwal et al. teach in figures 1-21 a semiconductor device comprising:

- a semiconductor substrate 50;
- an insulating layer 60 provided over the substrate; and
- a platinum metal layer 74 provided over the insulating layer to form a lower capacitor electrode 74, wherein the metal layer having a thickness of approximately 50-300 angstroms and wherein a top surface of the metal layer 74 is down to the insulating layer (figure 3, column 5, lines 41-43). It is note that the process limitation (an electro-polished patterned) would not carry patentable weight in this claim drawn to a structure, because distinct structure is not necessarily produced. In re Thorpe, 227 USPQ 964 (Fed. Cir. 1985).

Regarding claims 36-39 and 41, Agarwal et al. teach in figures 1-21 a memory cell comprising:

- a platinum metal layer 74 provided over a substrate, the platinum metal layer 74 having a thickness of approximately 50-300 angstroms (figure 3, column 5, lines 41-43);
- a transistor 58 including a gate fabricated on the semiconductor substrate and including a source/drain region (54, 56) in the semiconductor substrate disposed adjacent to the gate (figure 3, column 5, lines 3-14); and

a container capacitor including a lower electrode 74, the lower electrode having a surface aligned over the source/drain region, the platinum metal layer forming the lower electrode. It is note that the process limitation (an electro-polished patterned) would not carry patentable weight in this claim drawn to a structure, because distinct structure is not necessarily produced. In re Thorpe, 227 USPQ 964 (Fed. Cir. 1985).

Regarding claims 55-58, Agarwal et al. further teach in figures 1-21 a container capacitor comprising:

a platinum lower electrode 74 provided within a first insulating layer 64, the platinum lower electrode 74 comprising a metal layer having a bottom wall and vertical sidewalls extending upwardly, wherein the metal layer 74 has a thickness of approximately 50-300 angstroms (figure 3, column 5, lines 41-43);

a second insulating layer 72 provided over the metal layer and in contact with the first insulating layer 64; and an upper electrode 70 provided over the second insulating layer 72. It is note that the process limitation (an electro-polished patterned) would not carry patentable weight in this claim drawn to a structure, because distinct structure is not necessarily produced. In re Thorpe, 227 USPQ 964 (Fed. Cir. 1985).

Regarding claim 59, Agarwal et al. further teach in figure 3 a container capacitor comprising: a barrier conductive layer 80.

Regarding claims 60-64, Agarwal et al. further teach in figures 1-21 a container capacitor comprising: a plurality of opening provided in the insulating layer; and a plurality of platinum lower capacitor electrodes provided along the bottom and sidewalls of respective ones of the openings, the platinum lower electrodes being formed as discrete metal layers, wherein the platinum electrodes 74 have a thickness of approximately 50-300 angstroms (figure 3, column 5, lines 41-43). It is note that the process limitations (an electro-polished patterned, formed) would not carry patentable weight in this claim drawn to a structure, because distinct structure is not necessarily produced. In re Thorpe, 227 USPQ 964 (Fed. Cir. 1985).

Regarding claims 51-54, Agarwal et al. further teach in figures 1-22 the integrated circuit is a memory module that includes a DRAM, a SRAM memory or a MCM memory.

8. Claims 29-32, 34-39, 41,44-47, 49 and 51-64 are rejected under 35 U.S.C. 102(e) as being anticipated by Xing et al. (U.S. 6,090,697).

Regarding claims 29-32 and 34-35, Xing et al. teach in figure 3 a semiconductor device comprising:

- a semiconductor substrate 300;
- an insulating layer 302 provided over the substrate; and
- a platinum metal layer 304 provided over the insulating layer to form a lower capacitor electrode, wherein the metal layer having a thickness of approximately 100-

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500 angstroms and wherein a top surface of the metal layer 304 is down to the insulating layer (figure 3, column 6, lines 13-17). It is note that the process limitation (an electro-polished patterned) would not carry patentable weight in this claim drawn to a structure, because distinct structure is not necessarily produced. In re Thorpe, 227 USPQ 964 (Fed. Cir. 1985).

Regarding claims 36-39 and 41, Xing et al. teach in figures 3 and 6a, a memory cell comprising:

a platinum metal layer 304 provided over a substrate, the platinum metal layer 304 having a thickness of approximately 100-500 angstroms (figure 3, column 6, lines 13-17);

a transistor including a gate fabricated on the semiconductor substrate and including a source/drain region in the semiconductor substrate disposed adjacent to the gate (figure 6a); and

a container capacitor including a lower electrode 304, the lower electrode having a surface aligned over the source/drain region, the platinum metal layer forming the platinum lower electrode. It is note that the process limitation (an electro-polished patterned, formed) would not carry patentable weight in this claim drawn to a structure, because distinct structure is not necessarily produced. In re Thorpe, 227 USPQ 964 (Fed. Cir. 1985).

Regarding claims 44-47 and 49, Xing et al. teach in figure 3 a processor-based system comprising:

a processor (column 13, lines 14-22); and

an integrated circuit coupled to the processor, at least one of the integrated circuit and processor comprising a container capacitor provided within an insulating layer 316, the container capacitor including a platinum lower electrode 304 having a thickness of approximately 50-300 angstroms (figure 3, column 6, lines 13-17), wherein a top surface of the metal layer 304 is below or at the same level with a top surface of the insulating layer 316. It is note that the process limitation (an electro-polished patterned) would not carry patentable weight in this claim drawn to a structure, because distinct structure is not necessarily produced. In re Thorpe, 227 USPQ 964 (Fed. Cir. 1985).

Regarding claims 55-58, Xing et al. teach in figure 3 a container capacitor comprising:

a platinum lower electrode 304 provided within a first insulating layer 316, the platinum lower electrode 304 comprising a metal layer having a bottom wall and vertical sidewalls extending upwardly, wherein the platinum metal layer has a thickness of approximately 100-500 angstroms (figure 3, column 6, lines 13-17); a second insulating layer 312 provided over the metal layer and in contact with the first insulating layer 316; and an upper electrode 314 provided over the second insulating layer 312. It is note that the process limitation (an electro-polished patterned) would not carry patentable weight

in this claim drawn to a structure, because distinct structure is not necessarily produced.

In re Thorpe, 227 USPQ 964 (Fed. Cir. 1985).

Regarding claim 59, Xing et al. teach in figure 3 a container capacitor comprising:
a barrier conductive layer 308.

Regarding claims 60-64, Xing et al. teach in figure 3 a container capacitor comprising: a plurality of opening provided in the insulating layer; and a plurality of platinum lower capacitor electrodes provided along the bottom and sidewalls of respective ones of the openings, the platinum lower electrodes being formed as discrete metal layers, wherein the platinum electrodes 304 have a thickness of approximately 100-500 angstroms (figure 3, column 6, lines 13-17). It is note that the process limitation (an electro-polished patterned, formed) would not carry patentable weight in this claim drawn to a structure, because distinct structure is not necessarily produced. In re Thorpe, 227 USPQ 964 (Fed. Cir. 1985).

Response to Arguments

Applicant argues that "the limitation **electropolished patterned** is simply not a product-by-process limitation, but rather a *resulting structure* having distinct and defined characteristics". It should be noted that claims 29, 36, 44, 55 and 59-60 are not directed to any method for making a semiconductor device, but rather, are directed to the resulting of a semiconductor device. Therefore, the process limitation recited in claims

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29, 36, 44, 55 and 59-60 (an electro-polished patterned) would not carry patentable weight in claims drawn to a structure because these claims are directed to the product, no matter how the product of these claims is actually made, and the patentability of the final product must be determined, not the patentability of the process, which in any case have not been presented in "product by process" claims. In re Thorpe, 227 USPQ 964 (Fed. Cir. 1985). Applicant's argument thus is not persuasive because the final structure of the metal formed by electropolished process as claimed does not distinguish from the final structure of the metal layer of Agarwal and Xing.

Also, Applicant argues that the patterned metal layer formed by "electropolished" process has resulting structure distinct from the resulting structure of the pattern metal layer 74 of Agarwal or metal layer 304 of Xing. However, Applicant fails to point out which claimed resulting structure is distinct from the resulting structure of the patterned metal layer 74 of Agarwal or metal layer 304 of Xing.

Applicant's arguments, addressed to the amended claims are considered in the rejections shown above.

Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Theresa T Doan whose telephone number is (571) 272-

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1704. The examiner can normally be reached on Monday to Thursday from 8:00AM - 6:00PM.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, WAEL FAHMY can be reached on (571) 272-1705. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see <http://pair-direct.uspto.gov>. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

TD
April 16, 2004.



PHAT X. CAO
PRIMARY EXAMINER